



PATENT

Case Docket No. MICRON.140DV1C1

Date: April 12, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Li et al.  
Appl. No. : 10/757,638  
Filed : January 13, 2004  
For : TECHNIQUE FOR HIGH  
EFFICIENCY  
METALORGANIC CHEMICAL  
VAPOR DEPOSITION  
Examiner : Unknown  
Group Art Unit : Unknown

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

April 13, 2004

(Date)

Jeffrey A. Hopkins, Reg. No. 53,034

TRANSMITTAL LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- (X) A PTO Form 1449 with eighteen (18) references (one enclosed).
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

Jeffrey A. Hopkins  
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Agent of Record  
Customer No. 20,995  
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INFORMATION DISCLOSURE STATEMENT

Applicant : Li et al.  
App. No. : 10/757,638  
Filed : January 13, 2004  
For : TECHNIQUE FOR HIGH EFFICIENCY  
METALORGANIC CHEMICAL VAPOR  
DEPOSITION  
Examiner : Unknown  
Group Art Unit : Unknown

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed is form PTO-1449 listing 18 references. Copies of disclosed U.S. patents and/or publications are not included pursuant to PTO waiver of the requirement under 37 C.F.R. § 1.98(a)(2)(i) for applications filed after June 30, 2003. Copies of other references, if listed, are enclosed.

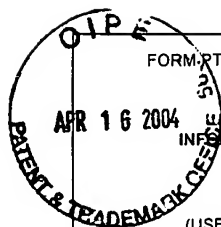
This Information Disclosure Statement is being filed with an RCE or within three months of the filing date of this application and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 4-12-2004

By: Jeffrey A. Hopkins  
Jeffrey A. Hopkins  
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FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
MICRON.140DV1C1APPLICATION NO.  
10757,638INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT

(USE SEVERAL SHEETS IF NECESSARY)

APPLICANT  
Li et al.FILING DATE  
January 13, 2004GROUP  
Unknown

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
	1	6,475,854	11/2002	Narwankar et al.			
	2	6,403,414	06/2002	Marsh			
	3	6,271,131	08/2001	Uhlenbrock et al.			
	4	6,201,271	03/2001	Okutoh et al.			
	5	6,180,974	01/2001	Okutoh et al.			
	6	6,140,230	10/2000	Li			
	7	5,902,651	05/1999	Westmoreland et al.			
	8	5,783,716	07/1998	Baum et al.			
	9	5,763,007	06/1998	Weiller			
	10	5,672,385	09/1997	Jimba et al.			
	11	5,576,071	11/1996	Sandhu			
	12	5,552,327	09/1996	Bachmann et al.			
	13	5,130,172	07/1992	Hicks et al.			
	14	US 2001/0000865 A1	05/2001	Gaughen et al.			
	15	US 2001/0043453 A1	11/2001	Narwankar et al.			
	16	US 2001/0044207 A1	11/2001	Marsh			
	17	US 2002/0076492 A1	06/2002	Loan et al.			

## FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)	
	18	Irving, Optical Diagnostics for Thin Film Processing, Academic Press, 1996, page 29.
	19	

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040904

EXAMINER	DATE CONSIDERED
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	